



IFW 2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:
Fumiaki MARUYAMA et al.

Application No.: 09/856,139

Filed: May 29, 2001

For: WAFER AND EPITAXIAL WAFER, AND
MANUFACTURING PROCESSES
THEREFOR

Atty Dkt No.: ISH-0247

Confirmation No.: 3293

Art Unit: 2814

Examiner: A. D. Mai

**SUBMISSION OF REVOCATION OF POWER OF ATTORNEY AND
STATEMENT UNDER 37 CFR 3.73(b)**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Submitted herewith are a Revocation of Power of Attorney and New Power of Attorney, and Statement Under 37 CFR 3.73(b) for the above-identified application.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 18-0013, under Order No. ISH-0247 from which the undersigned is authorized to draw.

Dated: June 10, 2009

Respectfully submitted,

By 
Carl Schankowitch

Registration No.: 29,211

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